



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tzeng

Group Art Unit: 1762

Serial No: 09/501,114

Examiner: Wesley D. Markham

Filed: February 10, 2000

Docket No.: 220101-1010

For: Method of Plasma Enhanced
Chemical Vapor Deposition
of Diamond

#21/E
Jue
4/15/03

PRELIMINARY AMENDMENT (RCE)

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
APR 10 2003
TC 1700

Sir:

In regard to the above-referenced application, the Applicant submits the following Preliminary Response and remarks to be respectively entered and considered with the accompanying request for continued examination (RCE).

AUTHORIZATION TO DEBIT ACCOUNT

It is not believed that extensions of time or fees for net addition of claims are required, beyond those, which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary to allow consideration of this paper, such extensions are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to deposit account no. 20-0778.

CERTIFICATE OF MAILING (37 CFR 1.8)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope to the: Assistant Commissioner For Patents, Washington, D.C. 20231.

Jo Bryan

Date: April 1, 2003